PATENT

THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Application of:

Davis, et al.

Serial No.: 10/665,934

Confirmation No.: 6821

Filed:

September 19, 2003

For: Method Of Controlling Critical
Dimension Microloading Of
Photoresist Trimming Process By
Selective Sidewall Polymer

Deposition

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Group Art Unit: 2812

Examiner:

Brook Kebede

CERTIFICATE OF MAILING 37 CFR 1.8

I hereby certify that this correspondence is being deposited on January 6, 2005 with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450 Alexandria VA 22313-1450.

Date 5

Signature

RESPONSE TO OFFICE ACTION DATED OCTOBER 6, 2004

In response to the Office Action dated October 6, 2004, having a shortened statutory period for response set to expire on January 6, 2005, please enter the following response and reconsider the claims pending in the application for reasons discussed below. Although applicants believe that no fee is due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/7989/LYC, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper. Remarks begin on page 5 of this paper.